

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Rong-Hui Kao

Serial No.: 10/821,438

Filed: April 9, 2004

For: **Sidewall Spacer For Semiconductor
Device And Fabrication Method Thereof**

Confirmation No. 1354

Group Art Unit: 2812

Examiner: Ullah, Elias

TKHR Ref. 252011-2210

Top-Team Ref. 0503-A30442US

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop – AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed on November 9, 2006, has been carefully considered. In response thereto, Applicants hereby submit the following remarks.